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**TRANSMITTAL LETTER FOR RESPONSE**

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Attorney Docket No. **1003-0610**

In re patent application of: **Newell E. Chiesl**

Serial No. **09/960,441**

Filing Date: **September 21, 2001**

Examiner: **Allan R. Wilson**

Group Art Unit: **2815**

For: **Arrangement for Measuring Pressure on a Semiconductor Wafer and an  
Associated Method for Fabricating a Semiconductor Wafer**

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS:

Transmitted herewith is a Response in the above-identified patent application. The fee has been calculated as shown below.

CLAIMS AS AMENDED				
	Claims Remaining After Amendment	Highest No. Paid For	Fee Calculation	Addit Fee
Total Claims	20	20	0 X 18	\$ 0
Independent Claims	3	3	0 X 84	\$ 0
Total Additional Fee Required				\$ 0

\* Please provide any extensions of time which may be necessary and charge any fee which may be due to Deposit Account No. 13-0014, but not to include any payment of issue fees.

Respectfully submitted,

Harold C. Moore  
Attorney for Applicants  
Registration No. 37,892

August 19, 2002  
Maginot, Moore & Bowman  
Bank One Tower/Center  
111 Monument Circle, Suite 3000  
Indianapolis, Indiana 46204-5115  
(317) 638-2922



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assistant Commissioner of Patents  
Washington, D.C. 20231

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Washington, D.C. 20231 on August 19, 2002

(Date of Deposit)

Harold C. Moore

Name of person mailing Document or Fee

Signature [Signature]

August 19, 2002

Date of Signature

Re: Application of : Newell E. Chiesl  
Serial No.: 09/960,441  
Confirmation No.: 5776  
Filed: September 21, 2001  
For: Arrangement for Measuring Pressure on a  
Semiconductor Wafer and an Associated  
Method for Fabricating a Semiconductor  
Wafer  
Group Art Unit: 2815  
Examiner: A. Wilson  
Our Docket No.: 1003-0610

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement dated July 17, 2002 for the above-  
identified patent application, please consider the following election.

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